

# INITIAL PRODUCT/PROCESS CHANGE NOTIFICATION Generic Copy

#### 08-May-2006

SUBJECT: ON Semiconductor Initial Product/Process Change Notification #15528

**TITLE: Additional SO8 Capacity for Integrated Power Devices** 

EFFECTIVE DATE: 15-Sep-2006

AFFECTED CHANGE CATEGORY: ON Semiconductor Assembly

**AFFECTED PRODUCT DIVISION: Integrated Power Devices** 

#### FOR ANY QUESTIONS CONCERNING THIS NOTIFICATION:

Contact Sales Office or Tom Huettl <S21431@onsemi.com>

#### NOTIFICATION TYPE:

Initial Product/Process Change Notification (IPCN)

First change notification sent to customers. IPCNs are issued at least 120 days prior to implementation of the change. An IPCN is advance notification about an upcoming change and contains general information regarding the change details and devices affected. It also contains the preliminary reliability qualification plan.

The completed qualification and characterization data will be included in the Final Product/Process Change Notification (FPCN).

This IPCN notification will be followed by a Final Product/Process Change Notification (FPCN) at least 60 days prior to implementation of the change.

#### DESCRIPTION AND PURPOSE:

ON Semiconductor is pleased to announce the addition of backend manufacturing capacity for their SO8 MOSFET product lines. This will be accomplished by qualifying these devices at an internal manufacturing site in Carmona, Philippines. The Carmona facility currently runs the SO8 package for other ON Semi product lines. In addition to this internal manufacturing site, ON Semiconductor will continue to manufacture SO8 products at their external subcontractors: Advanced Interconnect Technologies in Indonesia and Amkor Technology Philippines Inc. in the Philippines.

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#### **QUALIFICATION PLAN:**

- 1) High Temperature Gate Bias
  - Temp=150'C, Vgs=20V, Sample Size= 40pcs, Duration=1008Hrs
- 2) High Temperature Reverse Bias
  - Temp=150'C, Vgs=24V, Sample Size=240pcs, Duration=1008Hrs
- 3) Preconditioning
  - IR @ 260'C, HAST, IOL, Temp Cycle, Autoclave
- 4) Highly Accelerated Stress Test
  - Temp=130'C, Relative Humidity=85%, Pressure=18.8psi, Vds=24V, Duration=96Hrs
- 5) Intermittent Operatin Life
  - TA=25'C, Delta Temp=100'C, Dwell Time=2min On/Off, Duration= 15000 Cycles
- 6) Temperature Cycling
  - Temperature Extremes= -65'C/+150'C, Dwell Time=10 min, Duration=1000 Cycles
- 7) Autoclave Test
  - Temp=121'C, Rel Humidity=100%, Pressure=15psi, Duration=96Hrs
- 8) Scanning Acoustical Topography
- 9) Resistance to Solder Heat
- 10) Solderability
- 11) Destructive Physical Analysis
- 12) Bond Pull Strength
- 13) Die Shear
- 14) Bond Shear

#### AFFECTED DEVICE LIST:

NTMD6N03R2G

NTMD6N03R2

NTMD4N03R2G

NTMD4N03R2

NTMD6N02R2G

MMDF3N04HDR2G

NTMD6N02R2

MMDF3N02HDR2

MMDF1N05ER2G

MMDF2N02ER2

MMDF2N02ER2G

MMDF1N05ER2

MMDF3N02HDR2G

MMDF3N04HDR2

NTMD3N08LR2

SMVDF3N06VLR2

MMDF7N02ZR2

MMDF3N06VLR2

MMDF6N02HDR2

MMDF3N03HDR2

MMDF6N03HDR2

NTMD3N08LR2G

NTMD2C02R2G

MMDF2C03HDR2G

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NTMD2C02R2

MMDF2C03HDR2

NTMD2C02R2SG

NTMC1300R2

MMDF2C02ER2

MMDF2C02HDR2

NTMS3P03R2G

NTMS10P02R2

MMSF3P02HDR2

NTMS5P02R2G

NTMS5P02R2

NTMS10P02R2G

MMSF3P02HDR2G

MMSF7P03HDR2G

NTMS5P02R2SG

MMSF3P02HDR2SG

MMSF7P03HDR2

NTMS3P03R2

NTMS4112PR2

NTMS4P01R2

MMSF5P02HDR2

NTMS4705NR2G

NTMS4706NR2G

NTMS7N03R2G

STMS3300R2

NTMS7N03R2

NTMS4704NR2

NTMS4700NR2G

NTMS4N01R2

NTMS4704NR2G

NTMS4705NR2

NTMS4706NR2

NTMS4N01R2G

MMSF1310R2 STMS3300R2G

31W33300K2G

NTMS4404NR2

NTMS4700NR2

NTMSD3P102R2SG

NTMSD3P303R2G

NTMSD3P303R2

NTMSD2P102LR2

NTMSD2P102LR2G

NTMSD2P102R2

NTMSD2P102R2SG

NTMSD3P102R2

NTMSD3P102R2G

MMDFS2P102R2

MMDFS3P303R2

NTMSD6N303R2SG

NTMSD6N303R2

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### **Initial Product/Process Change Notification #15528**

NTMSD6N303R2G MMDFS6N303R2 NTMD2P01R2G NTMD3P03R2G MMDF2P02HDR2 MMDF2P02ER2 MMDF2P02ER2G MMDF2P02HDR2G NTMD2P01R2 NTMD3P03R2 MMDF4P03HDR2

MMDF2P03HDR2